

Application No. Not Yet Assigned  
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Attorney Docket No. 1217-050618

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : Not Yet Assigned

Applicants : Hideo SENOO et al.

Filed : Concurrently Herewith

Title : PROTECTIVE STRUCTURE OF  
SEMICONDUCTOR WAFER, METHOD  
FOR PROTECTING SEMICONDUCTOR  
: WAFER, MULTILAYER PROTECTIVE SHEET  
USED THEREIN, AND METHOD FOR  
: PROCESSING SEMICONDUCTOR WAFER

International Application No. : PCT/JP2003/010570

International Filing Date : 21 August 2003

Priority Dates Claimed : 28 August 2002  
4 December 2002

**MAIL STOP PCT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to initial examination, please amend the above-identified patent application as follows:

**Amendments to the Specification** begin on page 1 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Amendments to the Abstract** begin on page 7 of this paper.

**Remarks** begin on page 8 of this paper.